

LIST OF PRIOR ART CITED BY APPLICANT (Use several sheets if necessary)	ATTY. DOCKET NO. 1998/F-085 (8602*22)	SERIAL NO. 09/744621 To be Assigned
	APPLICANT: Diether Rueppel <i>et al.</i>	
	FILING DATE: Herewith	GROUP:

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
S.T.	AA	4,661,104	4/28/87	von Bittera <i>et al.</i>	604	896	
S.T.	AB	5,066,908	11/19/91	Takahashi	324	158	
	AC						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
S.T.	AL	0,754,562	1/22/97	<del>EPO</del> EP			X Abstract	
S.T.	AM	97/48740	12/24/97	World (in English)				
	AN							
	AO							
	AP							
	AQ							
	AR							
	AS							
	AT							

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

S.T.	AR	Kurisaki Yoshi, <u>Pat. Abs. of Japan</u> 3: No. 157, Abstract of JP 54 132235, "Sublimable Insecticide," (10/15/79)
S.T.	AS	Takahashi Yasushi, <u>Pat. Abs. of Japan</u> 14: No. 533, Abstract of JP 02 224354, "Inpsection of Deviation of Contact Hole in Semiconductor Device," (9/6/90)
	AT	
EXAMINER S.T.		DATE CONSIDERED 4/25/02